01-17-2002

FORM PTO-1595 (Rev. 6-93) 101949981

DEPARTMENT OF COMMERCE Patent and Trademark Office

01/09/02 RECORDATION PATE	ENTS ONLY	
To the Commissioner for Patents	Attorney Docket No.: 041501-5454	
Please record the attached original documents or copy th		
1. Name of conveying party(ies):	2. Name and address of receiving party(ies):	
Kye Hyun BAEK	Name: Hynix Semiconductor Inc.	
Additional names of conveying party(ies) attached? [] Yes [X] No	Name: Hynix Semiconductor Inc. Internal Address: Street Address: San 136-1, Ami-ri, Bubal-eub,	
	Street Address: San 136-1, Ami-ri, Bubal-eub, Ichon-shi, Kyoungki-do, Korea	
3. Nature of conveyance:	City: State: Zip:	
[X] Assignment [] Merger [] Security Agreement [] Change of Name [] Other	Additional name(s) & address(es) attached?	
Execution Date: <u>December 10, 2001</u>	[]Yes [X] No	
4. New Application number(s) or patent number(s):		
If this document is being filed together with a new applied together with a new applie	cation the execution date of the application is: nber 10, 2001	
A. Patent Application No.(s)	B. Patent No.(s)	
Additional numbers attached: [] Yes [X] No		
5. Name and address of party to whom correspondence concerning document should be mailed:	6. Total number of applications and patents involved: 1	
Name: Robert J. Gaybrick	7. Total fee (37 C.F.R. §3.41):\$40.00 [X] Enclosed [] Authorized to be charged to Deposit Account 50-0310	
Internal Address: Morgan, Lewis & Bockius LLP Customer No. 09629	8. Deposit Account No. 50-0310 (Attach duplicate page if paying by deposit account)	
Street Address: 1800 M Street, N.W. City: Washington State: D.C. Zip: 20036		
9. Statement and Signature To the best of my knowledge and belief the foregoing in	nformation is true and correct and any attached copy is a true	
copy of the original document.	A	
Robert J. Goodell Reg. No. 41,040	January 9, 2002	
Name of Person Signing Signatur	re Date I number of pages including cover sheet, attachments and documents: 2	
MDHAMM1 00000172 10040490		

01/14/2002

02 FC:581

ASSIGNMENT

WHEREAS I/We, the below named inventor(s), [hereinafter referred to as Assignor(s)], have made an invention entitled:

METHOD FOR MINIMIZING VARIATION IN ETCH RATE OF SEMICONDUCTOR WAFER CAUSED BY VARIATION IN MASK PATTERN DENSITY

Letters Patent on, (Serial No		ned an application for United States	
WHEREAS, <u>Hynix Semiconductor Inc.</u> , Bubal-eub, Ichon-shi, Kyoungki-do, Korea (herein interest in and to this invention, the application for U upon this application;		ecuring the entire right, title, and	
NOW THEREFORE, be it known that, for gacknowledged, I/WE, as assignor(s), have sold, assign unto the assignee, its lawful successors and assigns, Mapplication, and all divisions, and continuations there all reissues thereof; and I/WE hereby authorize and reall Letters Patent for this invention to assignee, its sur	MY/OUR entire right, title, and interest in and to eof, and all Letters Patent of the United States vequest the Commissioner of Patents and Trader	ell, assign, transfer, and set over to this invention and this which may be granted thereon, and marks of the United States to issue	
AND, I/WE HEREBY further covenant and agree that I/WE will, without further consideration, communicate with assignee, its successors and assigns, any facts known to ME/US respecting this invention and testify in any legal proceeding, sign all lawful papers when called upon to do so, execute and deliver all papers that may be necessary or desirable to perfect the title to this invention in said assignee, its successors and assigns, execute all divisional, continuation, and reissue applications, make all rightful oaths and generally do everything possible to aid assignee, its successors and assigns, to obtain and enforce proper patent protection for this invention in the United States, it being understood that any expense incident to the execution of such papers shall be borne by the assignee, its successors and assigns.			
AND, I/WE HEREBY authorize and request the attorneys I/WE have empowered in the Declaration and Power of Attorney in this application, to insert here in parentheses (Application No, filed) the filing date and application number of said application when known. January 9, 2002			
IN TESTIMONY WHEREOF, I/WE have hereunto set our hand(s).			
Full Name of Sole or First Assignor Kye Hyun BAEK	Assignor's Signature	Date ()20-10,20-1	
Address	the Hall broke	Citizenship	
322-20, Sang-dong, Wonmi-gu, Puchon-shi, Kyoungki-do, Korea		Republic of Korea	
Names of additional inventors attached [] Yes	[X] No		

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PATENT REEL: 012461 FRAME: 0306